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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AUG 31 2005

Application of

Applicants : Er-Xuan Ping
Serial No. : 10/732,962
Filed : December 11, 2003
Confrm No. : 9292
Title : **EVEN NUCLEATION BETWEEN SILICON AND OXIDE
SURFACES FOR THIN SILICON NITRIDE FILM GROWTH**
Docket No. : MIO 0088 V3/40509.280
Examiner : D. Nhu
Art Unit : 2818

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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William A. Jividen

42,695
Reg. No.

Sir:

AMENDMENT

This paper is being filed in response to the Office Action mailed June 28, 2005.

Reconsideration of the present application is respectfully requested in light of the amendments and remarks below, which include, in order of appearance, beginning on separate sheets:

Amendments to the Claims; and

Remarks.